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Docket No.: M-10693 US

February 27, 2003

**Box DAC** 

Commissioner For Patents Washington, D.C. 20231

Re:

Applicant(s):

STEVE BIELLAK ET AL.

Assignee:

KLA-TENCOR TECHNOLOGIES CORPORATION

Title:

SYSTEM AND METHODS FOR A WAFER INSPECTION SYSTEM USING MULTIPLE ANGLES AND MULTIPLE

WAVELENGTH ILLUMINATION

Serial No.:

09/891,693

Examiner: Docket No.: Hao Q. Pham M-10693 US

Filed:

June 26, 2001

Group Art Unit: 2877

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

(1) Return Receipt Postcard;

(2) This Transmittal Letter (in duplicate);

(3) Petition To Revive Unintentionally Abandoned Patent Application;

(4) Response to Office Action;

(5) Information Disclosure Statement, PTO-1449 and cited references

(6) Check for 2,396.00.

OFFICE OF PETITIONS

MAR 0 7 2003

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No additional fee is required.

The fee has been calculated as shown below:

## CLAIMS AS AMENDED

		Claims Remaining <u>After Amendment</u>		Highest No. Previously Paid For		Present Extra		Rate	Additional <u>Fee</u>
Total Claims		83	Minus	45	=	38	x	\$18.00	\$ 684.00
Independent Claims		7	Minus	4	=	3	х	\$84.00	\$ 252.00
	Information Disclosure Statement filing fee								\$ 180.00
□ Fee for Petition To Revive									\$ 1,280.00
Total additional fee for this Amendment:									\$ 2,396.00
$\boxtimes$	A chec	k is enclosed in the am	ount of						\$ <u>2,396.00</u>
							1	Total:	\$ 2,396.00

**EXPRESS MAIL LABEL NO.:** EU 877118232 US

Respectfully s ibmitted,

Attorney for Applicants Reg. No. 29,545